ttorney's Docket No.: 042390P10625

RESPONSE UNDER 37 C.F.R. § 1.116 **EXPEDITED PROCEDURE EXAMINING GROUP 2825** 

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Pa	atent Application of:	)	
	Jack Hwang, et al.	) ) 	T TT A
Application No.: 09/887,910		)	Igwe U. Anya 2825
Filed:	June 22, 2001	) Art Offit: )	2023
For:	A METHOD OF MAKING A SEMICONDUCTOR TRANSISTOR BY IMPLANTING IONS INTO A GATE DIELECTRIC LAYER THEREOF	) ) ) ) )	
Mail Stop AF Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450			
RESPONSE AFTER FINAL ACTION UNDER 37 C.F.R. § 1.116			
Dear Sir:			
In response to the Final Office Action mailed on August 20, 2003, Applicant			
respectfully requests that the Examiner reconsider the application in light of the			
following remarks.			
FIRST CLASS CERTIFICATE OF MAILING			
I hereby certify that this correspondence is being deposited with the United States Postal Service as first-class mail with sufficient postage in an envelope addressed to the Assistant Commissioner for Patents, Washington, D.C., 20231 on:			
October 17, 2003			
Date of Deposit			
Linda K. Brost  Name of Person Mailing Correspondence			
(	Gudak. Brost	<u>Octobu</u>	17,2003
	Signature		Date
Jack Hwa Serial No	ing, et al. .: 09/887,910 - 1 -	Ex	kaminer: Igwe U. Anya Art Unit: 2825